

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Patent Application of

NAKAYAMA ET AL.

Atty. Ref.: 925-342

Serial No. 10/581,247

Group: 2811

Filed: May 31, 2006

Examiner: Unknown

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREFOR

\* \* \* \* \*

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INFORMATION DISCLOSURE STATEMENT**

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449.

- ☐ All listed documents are attached.
- ☒ Copies of U.S. Patent Publications are not required and are not attached.
- ☒ Listed foreign patent publications and other documents are enclosed.
- ☒ The EP 1215730 reference corresponds to the WO 01/018872 reference; U.S.

Patent 6,121,633 corresponds to the JP 2002-514355 reference; and U.S. Patent 5,958,132 corresponds to the JP 7-267795 reference..

☒ The listed documents were cited in the ISR and copies are submitted herewith for the Examiner's consideration in this US National Phase Application.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.


The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

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Serial No. 10/581,247

The Commissioner is authorized to charge the undersigned's deposit account #14-1140 in whatever amount is necessary for entry of these papers and the continued pendency of the captioned application.

Respectfully submitted,  
NIXON & VANDERHYE P.C.

January 8, 2007

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